



PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Teruaki FUKAMI

Serial No: 09/218,997

Filed: December 22, 1998

For: SILICON WAFER STORAGE WATER
AND SILICON WAFER STORAGE
METHOD

Art Unit: 1744

Examiner: I. Soubra

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Commissioner for Patents

Washington, D.C. 20231

Dear Sir:

Please recognize the following as my associate attorneys in the above-entitled application:

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Please associate this case with this firm's customer number:

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PATENT TRADEMARK OFFICE

Respectfully submitted,

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Date: November 15, 2001

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